Claim 1 (amended). A method for removing structures, which comprises the steps of:

providing a substrate;

forming the structures on the substrate from a material selected from the group consisting of noble metals, oxides of noble metals, and ferroelectric materials;

> depositing a sacrifice layer on the structures and the substrate; and

removing the structures and the sacrifice layer in a polishing step.

FAX RECEIVED

GROUP 1700

GROUP 1700